



[10191/1993]

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Richard SPITZ et al.  
Serial No. : 09/914,404  
Filed : December 13, 2001  
For : **METHOD FOR PRODUCING HEAVILY-DOPED  
SEMICONDUCTOR COMPONENTS**

Group Art Unit : 2823

Examiner : Michelle Estrada

Confirmation No. : 5115

Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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Date: 3/9/2004

Signature: \_\_\_\_\_

**AARON C. DEDITCH**  
(33,865)

**AMENDMENT**

S I R:

In response to the Office Action mailed on December 3, 2003 (the three-month response date for which has been extended by one month from March 3, 2004 to April 3, 2004 by the accompanying Transmittal And Petition To Extend), please reconsider the above-identified application based on the following:

**Amendments to the Claims** are reflected in the listing of the claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.